



Docket No.: M4065.0159/P159-C
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Li Li, et al.

Allowed: November 5, 2003

Application No.: 09/991,982

Confirmation No.: 4481

Filed: November 26, 2001

Art Unit: 1765

For: METHOD OF CONTROLLING
STRIATIONS AND CD LOSS IN
CONTACT OXIDE ETCH

Examiner: B: Tran

COMMENTS ON EXAMINER'S STATEMENT OF REASONS FOR ALLOWANCE

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicants agree in part with the Examiner's statement for allowance in that the prior art of record fails to disclose the limitations noted by the Examiner. However, the Examiner's statement does not reflect all of the language of each of the allowed claims. The totality of the language of each claim provides additional reasons for the allowance of each claim.

Dated: February 2, 2004

Respectfully submitted,

By 

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